



EPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	Matthew Prince et al.	§	Art Unit:	3723
Serial No.:	10/762,849	§	Examiner:	Hadi Shakeri
Filed:	January 22, 2004	§	Docket:	ITL.0941US
For:	Reducing Wafer Defects from Chemical Mechanical Polishing	§	Assignee:	Intel Corporation

Mail Stop **Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO OFFICE ACTION

Sir:

In response to the office action mailed May 9, 2006, reconsideration is requested in view of the following remarks.

A current listing of the claims is attached. No amendments were made.

Date of Deposit: July 13, 2006

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
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